



08-29-05

PATENT  
790001-2042

*FW*

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : NAKAMURA et al.  
Serial No. : 10/752,642  
Filing Date : January 7, 2004  
For : **SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING  
THE SAME**  
Examiner : Jesse A. Fenty  
Art Unit : 2815

745 Fifth Avenue  
New York, NY 10151

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Date of Deposit: August 26, 2005

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" Service under 37 CFR 1.10 on the date indicated above and is addressed to: **Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.**

*Adam Ahmed*

(Typed or printed name of person mailing paper or fee)

*17660801*

(Signature of person mailing paper or fee)

**AMENDMENT UNDER 37 C.F.R. § 1.111  
AND REQUEST FOR INTERVIEW**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the **May 26, 2005** Office Action, setting a three month term for reply.